

Attorney Docket No: 0492611-0543/MIT9277CON1

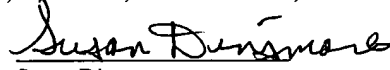
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Seleznev, *et al* Examiner: To be assigned
Serial No.: 10/799,436 Art Unit: 1751
Filing Date: March 12, 2004
Title: VACUUM PROCESSING FOR FABRICATION OF
SUPERCONDUCTING THIN FILMS FABRICATED BY METAL-
ORGANIC PROCESSING

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on February 25, 2005.


Susan Dinsmore

Sir:

Preliminary Amendment

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 8 of this paper.